

03500.010530.5

PATENT APPLICATION

2823
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KIYOFUMI SAKAGUCHI, ET AL.

Application No.: 10/085,046

Filed: March 1, 2002

For: PROCESS FOR PRODUCTION OF
SEMICONDUCTOR SUBSTRATE

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) Examiner: G. Fourson, III
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) Group Art Unit: 2823
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November 3, 2004

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**AMENDMENT, SUBSTANCE OF
INTERVIEW, AND PETITION FOR EXTENSION OF TIME**

Sir:

Applicants petition to extend the time for response to the Office Action dated June 8, 2004 to November 8, 2004. A check in the amount of \$430.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

11/05/2004 RFEKADU1 00000047 10085046

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